IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Naofumi Nakamura et al.

Serial No. : 10/752.642

For : SEMICONDUCTOR DEVICE AND METHOD OF

FABRICATING THE SAME

Filing Date : January 7, 2004

Examiner : Jesse A. Fenty

Group Art Unit : 2815 Confirmation No. : 4109

> 745 Fifth Avenue New York, NY 10151

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being transmitted via Electronic Filing Services on

_ Thomas J. Kowalski, Reg. No. 32.147

of person signing transmittal)

May 2, 2007

Date of Signature

AMENDMENT AND PETITION FOR A TWO-MONTH EXTENSION OF TIME SUBMITTED WITH A REQUEST FOR CONTINUED EXAMINATION

MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed on November 2, 2006, having a threemonth shortened statutory period for reply set to expire on February 2, 2007, and the Advisory Action mailed on March 27, 2007 in the above-captioned application, Applicants' attorneys submit herewith a Request for Continued Examination and respectfully request amendment of the above-identified application as follows. Petition for Extension of Time is included on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 4 of this paper.

Remarks/Arguments begin on page 8 of this paper.